

10/532473

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OGOSH31USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:	)	
	)	Examiner:
Kunihiro Oda	)	
	)	Group Art Unit:
Application No.:	)	
	)	
Corresponding International Filing No.:	)	
PCT/JP03/09574	)	
	)	
Filed: Herewith	)	
	)	
For: Ta SPUTTERING TARGET AND	)	
METHOD FOR PREPARATION	)	
THEREOF	)	

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SECOND PRELIMINARY AMENDMENT

Sir:

Please amend the above-identified patent application as follows.

**Amendments to the Specification** begin on page two of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on  
page three of this paper.

**Remarks** begin on page seven of this paper.